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Tunable electrical properties of self-organized zirconia nanotubes

Florence Vacandio*, Marielle Eyraud, Philippe Knauth, Thierry Djenizian

LCP, Electrochemistry of Materials Research Group, UMR 6264, Aix-Marseille University, CNRS, Campus de Saint-Jérôme, Marseille cedex 20, F-13 397, France

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ABSTRACT

Structural and electrical properties of self-organized zirconia nanotube layers can be tuned by a simple thermal treatment. The effect of F on the electrical conductivity of the MO_x nanotubes grown by anodization in fluoride-containing electrolytes is demonstrated.

1. Introduction

Zirconia is known to have remarkable properties and to be an electrical insulator which can become a pure ionic conductor if doped (Y₂O₃, Gd₂O₃...) [1,2]. This leads to technological applications such as industrial catalysts and catalyst supports [3], oxygen sensors [4], solid electrolyte fuel cells (SOFC) [5]. Pure zirconia can be found in three crystallographic structures: monoclinic until 1170 °C, tetragonal between 1170 °C and 2370 °C and cubic above 2370 °C. However, only the tetragonal phase gives ceramics with satisfying mechanical properties. This phase can be stabilized at room temperature by doping with bivalent or trivalent cations, especially by yttrium. During the last decades, the use of porous materials has attracted attention in various domains and particularly in the field of energy. Porous materials have the advantage of large specific surface that can increase the performances of the materials while reducing the size and weight of the components. A possible way to grow highly-ordered nanostructures is the anodization of valve metals such as Ti [6,7], Hf [8], Zr [9–16] in fluoride-containing electrolytes. Most of these nanostructured oxides are obtained by anodization of metallic foils, which limits their application in functional microdevices. An interesting alternative opening the path towards a wide range of applications is the anodization of thin films. Thus, in previous work, we have reported the synthesis of self-organized TiO₂ nanotubes from sputtered Ti thin layers deposited on Si [17–24].

In this paper, we report the fabrication of ZrO₂ nanotubes (ZrO₂nt) by anodization of thin layers of Zr deposited by cathodic sputtering on Si substrates. We study the influence of annealing upon the

morphological, structural and electrical properties of nanotubes by Scanning Electron Microscopy (SEM), Energy Dispersive Spectroscopy (EDS), X-ray Diffraction (XRD) and Electrochemical Impedance Spectroscopy (EIS) measurements.

2. Experimental section

Zirconium thin films were deposited by cathodic sputtering using a DC triode system on Si substrates (4 × 4 cm²) prepared from p-type Si (100) wafers with a resistivity of 1–10 Ω.cm (Wafer World, Inc.). In order to remove the native oxide layer, the Si samples were dipped in 1% HF solution for 30 s, then rinsed in deionized (DI) water and dried under a nitrogen stream before being introduced into the chamber. A Zr metal disk (nominal purity 99.9%, diameter 5 cm) was the sputtering target and the base chamber pressure prior to depositions was kept as low as 10⁻⁷ mbar. The high-purity argon pressure and the target current during deposition were maintained at constant values of 7.10⁻⁴ mbar and 150 mA, respectively. Under these conditions, the deposition rate was 16 nm min⁻¹ and a 2.6 μm thick Zr film was obtained after 120 min. Zirconium layers were anodized at room temperature at 40 V during 10 min with a conventional two-electrode configuration, using an EG&G PARSTAT 2273 potentiostat/galvanostat. A platinum grid was used as counter electrode. The electrodes were immersed in a 0.35 M NH₄F, 5% vol. water and glycerol electrolyte.

Impedance measurements were performed in a 1 M (NH₄)₂SO₄ solution with in addition to the previous configuration a reference Calomel Saturated Electrode (ECS), using a Potentiostat–Galvanostat coupled with a Frequency Response Analyser (Solartron 1287 and 1260). Impedance diagrams were recorded at open circuit potential, with a signal amplitude of 20 mV and a frequency range starting from 100 kHz to 10 mHz. Samples were analyzed by X-Ray Diffraction

* Corresponding author. Tel.: +33 491 551837; fax: +33 491 551850.
E-mail address: florence.vacandio@univ-provence.fr (F. Vacandio).

(XRD) with $\text{CuK}\alpha$ radiation ($\lambda = 0.15406 \text{ nm}$) using a Siemens D5000 diffractometer; the processing software is BRUKER Diffra-eva. Scanning Electron Microscopy (SEM) observations were performed using a Philips XL 30 ESEM equipped with an energy-dispersive X-Ray spectrometer (EDS).

3. Results and discussion

The SEM images (Figs. 1 and 2) show the morphology of the self-organized zirconia nanotubes before and after annealing at 450°C during 3 h in air. The as-formed porous layer exhibits an uniform and ordered nanotube arrangement. The diameters of the ZrO_2 tubes are around 25–30 nm and the wall thickness is estimated to be approximately 5 nm. The examination of the SEM cross-section (not shown) reveals that the thickness of the ZrO_2 layer is about $2.1 \mu\text{m}$. Additionally, the presence of a remaining zirconium layer of about $0.8 \mu\text{m}$ indicates a thickness increase of 11.5% as the thickness of the sputtered zirconium layer was $2.6 \mu\text{m}$. After the thermal treatment, it can be noticed that the nanoporous matrix does not collapse and is not damaged (no fissure or crack can be seen by SEM). Although a fraction of the tubes are plugged, it is remarkable that the morphology as well as the dimensions of the nanotubes are still preserved.

The corresponding Energy Dispersive X-Ray Spectroscopy (EDS) spectra exhibit two peaks relative to Zr and O. However, as-prepared ZrO_2 nt shows a peak attributed to the presence of F in the oxide matrix. Insertion of F is supposed to take place during the anodization process through the decomposition of the F-containing electrolyte leading to the probable formation of a thin ZrF_4 layer embedding the external surface of the nanotubes. The formation of such a thin layer has been reported in the case of the electrochemical fabrication of titania nanotubes [25]. Another scenario for the incorporation of F could also be substitution of an oxygen atom by a fluorine atom in the oxide bulk near the surface. After annealing, the absence of the peak corresponding to fluorine suggests that it might evaporate as HF during the thermal treatment.

In Fig. 3 are presented the XRD patterns of the as-prepared and annealed ZrO_2 nt layers. The pattern for non-annealed sample shows the presence of a small peak at $2\theta = 34.9^\circ$ relative to the residual layer of hexagonal zirconium (JCPDS file N°005-0665). Four peaks located at $2\theta = 28.3; 31.5; 34.5$ and 51.1 are attributed to the ZrO_2 monoclinic phase (JCPDS File No 037-1484) and one peak at $2\theta = 50.6$ to the tetragonal phase (JCPDS File No 050-1089). After annealing, both monoclinic and tetragonal phases are still detected, but two additional intense peaks corresponding to the tetragonal modification appear revealing an increased proportion of tetragonal phase. This result shows that a simple annealing treatment can promote the phase that is known to exhibit good mechanical properties [26].

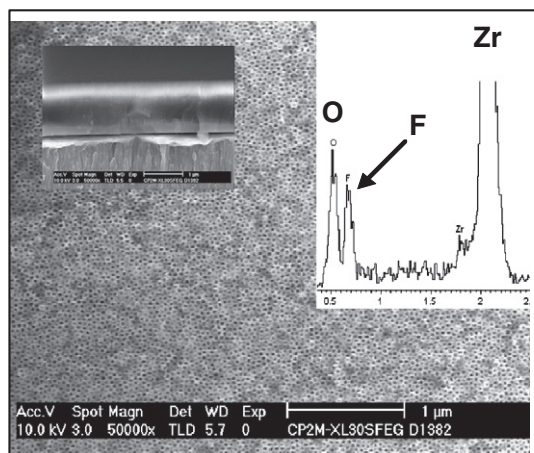


Fig. 1. SEM observation and EDS analysis of as-formed ZrO_2 nt.

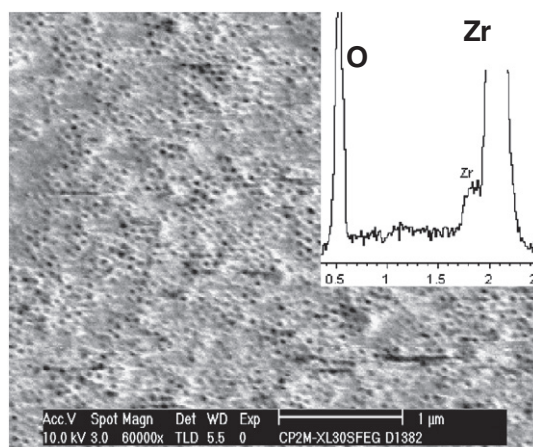


Fig. 2. SEM observation and EDS analysis of ZrO_2 nt after annealing.

Electrical properties of ZrO_2 nt before and after annealing were investigated by Electrochemical Impedance Spectroscopy (Fig. 4). The modulus of the impedance at high frequency is a good approximation of the resistance of the layer. The impedance modulus at low frequency is equal to $1.7 \cdot 10^5 \Omega \cdot \text{cm}^2$ for the as-formed ZrO_2 nt layer and equal to $3 \cdot 10^8 \Omega \cdot \text{cm}^2$ after annealing. While the insulating behaviour of the annealed ZrO_2 nt layer is comparable to pure zirconia reported in literature, the unexpected semiconductor behaviour observed before annealing can be explained by the presence of fluorine in the structure. Indeed, the insertion of fluorine ions occupying oxygen ion sites is responsible for the generation of excess electrons, as described in Kröger-Vink notation:



Thus, fluoride ions incorporated into zirconia nanotubes have a strong effect on the electrical properties, enhancing n-type conductivity. In contrary, the annealing in oxygen-containing atmosphere removes both F and electrons in ZrO_2 nt, as can be immediately concluded by reversing eq. (1). Clearly, the electrical conductivity of ZrO_2 nt decreases drastically when fluorine is removed from the structure. This is the first evidence of the direct effect of F^- upon the electrical properties of MO_x nanotubes prepared by electrochemical techniques. So far, this effect has been hidden by the intrinsic electrical behaviour of the studied materials; this is especially the case for TiO_2 nt that remains semiconducting. More generally, the results presented in this work demonstrate that the electrical properties of MO_x nt layers formed by anodization in fluoride-containing electrolytes could be tuned by an appropriate thermal treatment.

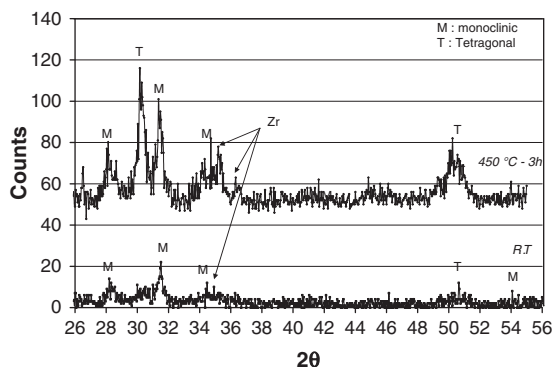


Fig. 3. X-ray diffraction (XRD) diagrams of ZrO_2 nt before and after annealing.

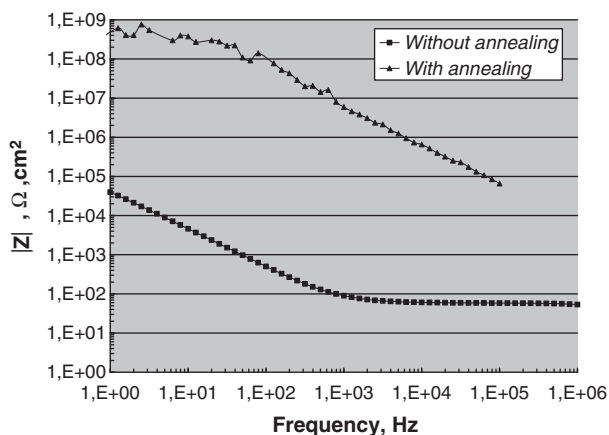


Fig. 4. Electrochemical impedance spectra of ZrO₂nt before and after annealing.

4. Conclusion

Electrochemical fabrication of zirconia nanotube thin films is described in fluoride-containing electrolyte. The annealing at 450 °C during 3 h in air does not affect the nanotubular morphology, but changes drastically the structural and electrical properties. Indeed, thermal treatment leads to an increase of the proportion of tetragonal phase, which is the most interesting due to the good mechanical properties. More remarkably, the electrical conductivity of the ZrO₂nt layer can be also turned from semiconductor to insulator after fluorine removal. This is the first evidence of the effect of F on the electrical properties of MO_x nanotubes fabricated by anodization of fluoride-containing electrolytes.

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